

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	GILL	Examiner:	EVANS, J.
Serial No.:	10/811,525	Group Art Unit:	2627
Filed:	03/29/2004	Docket No.:	HSJ920030222US1 (HITG.068-0562)
Title:	METHOD FOR FORMING THIN FILM HEADS USING A BI-LAYER ANTI-REFLECTION COATING FOR PHOTOLITHOGRAPHIC APPLICATIONS AND A STRUCTURE THEREOF		

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PETITION FOR EXTENSION OF TIME


Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.136, it is respectfully requested that a one-month extension of time be granted in which to file the attached Amendment. The charge of \$120.00 will be made by credit card.

Respectfully Submitted,

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By:   
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